



09/912558

CFK

Docket No.: M4065.0319/P319-A  
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Letters Patent of:  
Husam N. Al-Shareef et al.

Patent No.: 7,176,079

Issued: February 13, 2007

For: METHOD OF FABRICATING A  
SEMICONDUCTOR DEVICE WITH A WET  
OXIDATION WITH STEAM PROCESS

*Certificate  
MAR 02 2007  
of Correction*

**REQUEST FOR CERTIFICATE OF CORRECTION  
PURSUANT TO 37 C.F.R. § 1.322**

Attention: Certificate of Correction Branch  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

Upon reviewing the above-identified patent, Patentees noted an error which should be corrected.

In Claim 1, the following error is to be corrected:

Column 7, line 3, "thermal chamber" should read --thermal process chamber--.

The error was not in the application as filed by Applicants; accordingly no fee is required.

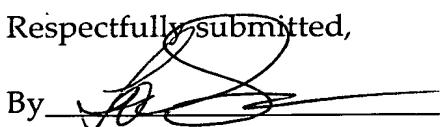
*MAR - 7 2007*

DSMDB-2219739v01

Transmitted herewith is a proposed Certificate of Correction effecting such amendment. Patentees respectfully solicit the granting of the requested Certificate of Correction.

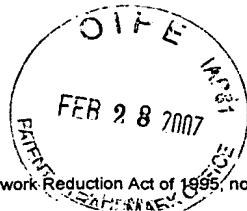
Dated: February 28, 2007

Respectfully submitted,

By   
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UNITED STATES PATENT AND TRADEMARK OFFICE  
CERTIFICATE OF CORRECTION

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PATENT NO. : 7,176,079  
APPLICATION NO. : 09/912,558  
ISSUE DATE : February 13, 2007  
INVENTORS : Husam N. Al-Shareef et al.

It is certified that an error appears in the above-identified patent and that said Letters Patent is hereby corrected as shown below:

In Claim 1, the following error is corrected:

Column 7, line 3, "thermal chamber" should read --thermal process chamber--.

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